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Filing Date		2004-02-27		
First Named Inventor	Trevor W. Freeman			
Art Unit		2139		
Examiner Name	Benjamin A Kaplan			
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U.S.PATENTS									
Examiner Initial*	Cite No	Patent Number	Kind Code ¹	Issue Date	Name of Patentee or Applicant of cited Document	Pages,Columns,Lines where Relevant Passages or Relevant Figures Appear			
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